ACTUATOR 2000

7th International
Conference on New Actuators
&
International Exhibition
on Smart Actuators and Drive Systems

19 - 21 June 2000
Bremen, Germany

Conference Proceedings

Editor
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Published by
MESSE BREMEN GMBH, Bremen, Germany

Printed in Germany by ASCO-Druck GmbH & Co. KG, Bremen
ISBN-3-933339-02-2

7th International Conference on New Actuators
International Exhibition on Smart Actuators and Drive Systems

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19 – 21 June, 2000
Bremen Fair and
Congress Center,
Germany

Organised by

MESSE BREMEN GMBH, Bremen, Germany

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Welcoming Remarks

Welcome to ACTUATOR 2000 in Bremen. This event continues a series of biennial functions in Bremen and consists of the *7th International Conference on New Actuators* and the *International Exhibition on Smart Actuators and Drive Systems*. Like its predecessors, ACTUATOR 2000 is a major meeting place for leading experts, scientists and managers from all over the world in the field of new actuators. Its main focus is on the transfer of new results from science and research into wide fields of application.

In response to many requests, we are now offering a wide range of application-oriented topics such as nanopositioning, microfluidics, vibration control and medical applications in additional conference sessions. This has been achieved by introducing a parallel track of oral presentations. The schedule has been compiled carefully to avoid time conflicts between related topics. Thus, we will have in total 78 oral presentations and 74 poster contributions this time, all portraying the state of the art and indicating future trends.

Oral sessions will be held in the following fields:

- Piezoelectric actuators
- Microactuators
- Magnetostrictive actuators
- Actuators based on ER/MR fluids
- Shape memory actuators
- Electromagnetic actuators
- Other actuators
- Microfluidics
- Piezoelectric actuators: applications
- Actuators for artificial limbs
- Nanopositioning
- Vibration control
- Shape memory actuators: applications
- Electromagnetic actuators: linear drives

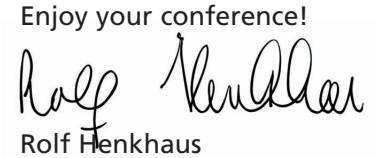
Some of the sessions will be kicked off by a 30-minute review presented by a member of the Programme Committee, followed by application-oriented presentations of 20 minutes each. The full manuscripts of nearly all the oral papers and poster contributions have been included in these proceedings and, as for 1998, in a separate CD-ROM.

Furthermore, we invite you to also visit the enlarged accompanying trade show with the exhibition forum right in its centre. Here, exhibitors accepted our invitation to give more product-oriented presentations. Thus, conference participants and visitors to the exhibition can inform themselves individually about the current state of actuator technology.

Our special thanks go to all those participants who are actively contributing to this event by sharing the results of their research work here – as authors of papers and posters, or as exhibitors – and thus possibly igniting new projects, initiating new co-operations, or paving the way for new business connections. We also thank the members of the Programme Committee for their excellent work and valuable assistance, and we are particularly grateful to the endorsing institutions and to all others who have supported our public relations work.

We are now looking forward to interesting presentations, lively discussions and helpful new contact, and we would be pleased to welcome you again in two years, for ACTUATOR 2002.

Enjoy your conference!



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Hubert Borgmann
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ACTUATOR 2002

8th International
Conference on New Actuators
&
2nd International Exhibition
on Smart Actuators and Drive Systems

June 2002
Bremen, Germany

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